

## SEARCHED

Class	Sub.	Date	Exmr.
250	492.22 492.2 398	2/13/02	JH
324	318 319 320 322		
313	440 431		

## INTERFERENCE SEARCHED

Class	Sub.	Date	Exmr.

SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)

	Date	Exmr.
PLUS Search	2/13/03	JH
Compensation Mt; (Coil on CIRCUIT) AND (Field non 4 (Lameter Nullify on zero)) AND (magnetic ad; Field 6; (sensors on detection on sensing on detecting)) and (Lithography on photography on photo- Lithography) and (R2; 16 on M5M on 10gmic on photomask)) on LCPB on SEM on ion Beam	2/13/03	JH
Compensation reliability near center circuit Same Field non (Lameter on null on zero) SAME Magnetic Field non Sensors on detection on detecting	2/13/03	JH
Compensation coil on CIRCUIT AND COB on SEM on e-beam And magnetic on Lithography on magnetic Field	2/13/03	JH